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Docket No. YOR920030013US1
YOR.427

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

David Abraham, et al.

Serial No.: 10/680,260

Group Art Unit: 2814

Filing Date: October 8, 2003

Examiner: Ahn D. Mai

For: METHOD AND SYSTEM FOR PATTERNING OF MAGNETIC THIN FILMS
USING CHEMICAL TRANSFORMATION

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Under the provisions of 37 CFR §1.97 through §1.98 and pursuant to applicants' duty of disclosure under 37 CFR §1.56, applicants respectfully bring the following document listed on the attached form PTO-1449, to the attention of the Examiner in charge of the above-identified application. A copy of the listed document is provided herewith for the convenience of the Examiner.

This citation does not constitute an admission that the reference is relevant or material to the claims. It is only cited as constituting related art of which applicants are aware.

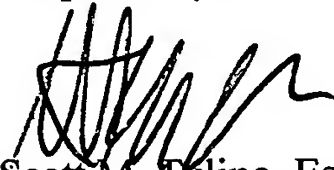
I hereby certify that no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in § 1.56(c) more than three months prior to the filing of the information disclosure statement.

It is respectfully requested that the listed reference be considered by the Examiner and formally made of record in this application.

Serial No. 10/680,260
Docket No. YOR920030013US1
YOR.427

Please charge any deficiencies in fees and credit any overpayment of fees to Attorney's
Deposit Account No. 50-0510.

Respectfully submitted,



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FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT <i>(Use several sheets if necessary)</i>	ATTY. DOCKET NO. YOR920030013US1	SERIAL NO. 10/680,260
	APPLICANT David Abraham, et al.	
	FILING DATE October 8, 2003	GROUP 2814

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO PART.		
	AG								
	AH								
	AI								
	AJ								
	AK								

OTHER REFERENCES *(Including Author, Title, Date, Pertinent Pages, Etc.)*

	AL	"Patterning Magnetic Films by Ion Beam Irradiation", J. Appl. Phys., Vol. 87, No. 9, 7004 (2000).							
	AM								
	AN								
EXAMINER					DATE CONSIDERED				

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.